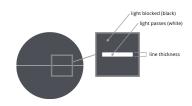


PT00000100P | DATASHEET

Single line pattern, Photolitography



Opto Engineering® supplies a comprehensive range of projection patterns compatible with our LED illuminators.

PT projection patterns can be either laser-engraved, with 50 μ m geometrical accuracy, or photolitography-engraved for more demanding applications (2 μ m accuracy).



SPECIFICATIONS

Туре		Single line
Process		Photolitography
Substrate		Soda lime glass
Coating		Chrome on glass
Line spacing	(mm)	-
Line thickness	(mm)	0.05
Dot size	(mm x mm)	-
Geometrical accuracy	(µm)	2
Edge sharpness	(µm)	1.4

Circular aperture (LTPR)

Active Area	(mm)	20
Number of lines		1
Max line length	(mm)	20

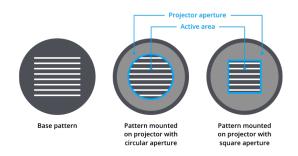
Square aperture (LTPRSM)

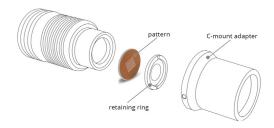
Active Area	(mm)	8 x 8
Number of lines		1
Max line length	(mm)	8

Mechanical specifications

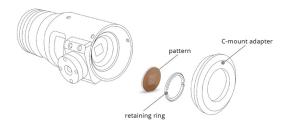
Diameter	(mm)	21
Thickness	(mm)	1.6

PTPR AND ACTIVE AREA





Pattern projector with circular aperture disassembled.



Pattern projector with square aperture disassembled.

COMPATIBLE PRODUCTS

Full list of compatible products available here.



A wide selection of innovative machine vision components.